



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Hyo-sang JUNG

Art Unit: 1762

Serial No. 10/068,005

Examiner: Marianne L. PADGETT

Filed: February 8, 2002

Confirmation No. 6445

For: VACUUM APPARATUS OF ION IMPLANTATION SYSTEM AND EVACUATION METHOD Atty. Docket No. 262/011

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**RECEIVED**

**MAR 01 2004**

Commissioner for Patents  
United States Patent and Trademark Office  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action mailed October 23, 2003, please amend the application identified above as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims begin on page 4.

Remarks are presented beginning on page 6.